

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of

Atsuro EITOKU

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Group Art Unit: 1746

Examiner: Alexander Markoff

For: SUBSTRATE TREATMENT APPARATUS AND SUBSTRATE TREATMENT METHOD  
VIA EFS-WEB

Commissioner for Patents

P.O. Box 1450

Alexandria, VA 22313-1450

SUBMISSION

Sir:

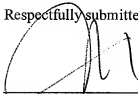
Submitted herewith is a copy of a search report issued by a patent searching authority other than the PTO and the cited art together with a form listing the same for the convenience of the Examiner. Please note JP11-260778 was previously cited in an Information Disclosure Statement filed July 26, 2007.

I certify that each item of information contained in this Submission was cited in a communication from a foreign patent office in a counterpart foreign application and that this communication was not received by any individual designated in 37 C.F.R. 1.56(c) more than 30 days prior to the filing of this Submission.

In the event the actual fee is greater than the payment submitted or is inadvertently not enclosed or if any additional fee due during the pendency of this application is not paid, the Patent and Trademark Office is authorized to charge the underpayment to Deposit Account No. 15-0700.

THIS CORRESPONDENCE IS BEING  
SUBMITTED ELECTRONICALLY  
THROUGH THE PATENT AND  
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SYSTEM ON November 1, 2007.

Respectfully submitted,



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